

LIST OF RELATED CASES

	Docket Number	Serial or Patent Number	Filing or Issue Date	Inventor/ Applicant	
A.D.A.	208546US2S	09/853,661	05/14/01	TANAKA	
AQA.	227579US2S	10/230,119	08/29/02	TANAKA	
AQA.	232835US2S	10/354,048	01/30/03	YAMAGUCHI et al.	
AQA.	237756US2	10/437,060	05/14/03	TANAKA	
AOA.	243492US2S	10/677,260	10/03/03	TANAKA et al.	
AO.A.	251363US2*	10/814,246	04/01/04	OKUNO et al.	

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Form PTO 1449		U.S. DEPARTMENT OF COMMERCE		ATTY DOCKET NO.		SERIAL NO.				
(Modified)		PATENT AND TRADEMARK OFFICE		251363US2		10/814,246				
LIST OF REFERENCES CITED BY APPLICANT			APPLICANT							
			Takahiro OKUNO, et al.							
	1_	AUG , a `-		FILING DATE		GROUP				
	当	1 0 2004 S		April 1, 2004						
U.S. PATENT DOCUMENTS										
EXAMINER INITIAL		NUMBER	DATE	NAME CLASS		SUB FILING DATE CLASS IF APPROPRIATE				
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						TRANSLATION				
		DOCUMENT NUMBER	DATE	COUNTRY		YES				
A.O.A.	AO	2003-204066 (2002-1784)	07/18/2003	JAPAN (with English Abstract)		<u> </u>	×			
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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)										
101	A)A/	I. OMURA, et al., IEEE	Transactions	on Electron Devices, vol. 46, no. 1, page	s 237-244	, "OSCILL	ATION EFFECTS IN			
I. OMURA, et al., IEEE Transactions on Electron Devices, vol. 46, no. 1, pages 237-244, "OSCILLATION IGBT'S RELATED TO NEGATIVE CAPACITANCE PHENOMENA", January 1999										
A .O.A.	AX	I. OMURA, et al., Proceedings of ISPSD, pages 25-28, "IEGT DESIGN CONCEPT AGAINST OPERATION INSTABILITY AND ITS IMPACT TO APPLICATION", May 25, 2000								
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	AZ				Add	itional Refe	erences sheet(s) attack	ned		
Examiner	Examiner O. O. Date Considered May 200									
*Examiner: initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.										